

1762

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of :

Barry Lee-Mean Yang et al.

: Examiner: Timothy Meeks

Serial No. 10/063,094

: Group Art Unit 1762

Filed: March 19, 2002

: Paper No.

For APPARATUS AND METHOD FOR  
LARGE AREA CHEMICAL VAPOR  
DEPOSITION USING MULTIPLE  
EXPANDING THERMAL PLASMA  
GENERATORS

**AMENDMENT AND REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

S I R:

In response to the Office Action mailed on May 5, 2004, please amend the above-referenced application as follows.

If any additional fees for the accompanying response are required, Applicants request that this be considered a petition therefore. The Director is hereby authorized to charge any fees that may be required to Deposit Account 07-0868.

**Amendments to the Claims** begin on page 2 of this paper; and

**Remarks** begin on page 6 of this paper.